



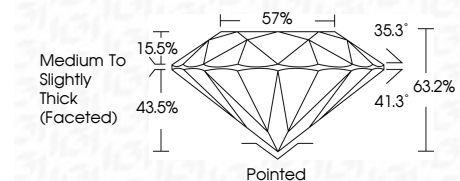
**ELECTRONIC COPY**

LG795693935  
Report verification at igi.org



April 30, 2026  
IGI Report Number **LG795693935**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **6.53 - 6.55 X 4.13 MM**

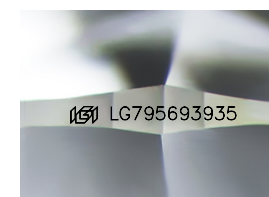
**GRADING RESULTS**  
Carat Weight **1.09 CARAT**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**



**ADDITIONAL GRADING INFORMATION**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **(IGI) LG795693935**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

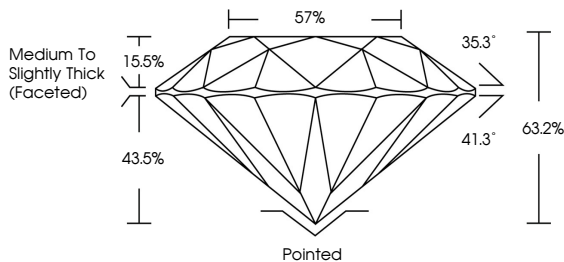


April 30, 2026  
IGI Report No LG795693935  
**ROUND BRILLIANT**  
6.53 - 6.55 X 4.13 MM  
1.09 CARAT  
F  
VVS 2  
EXCELLENT  
63.2%  
57%  
Medium To Slightly Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG795693935  
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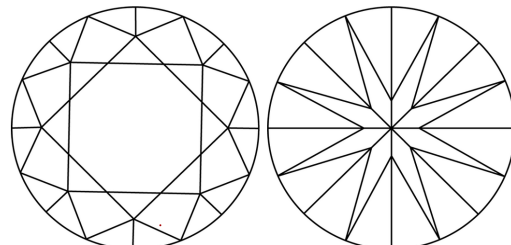


Sample Image Used

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**  
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D	E	F	G	H	I	J	Faint	Very Light	Light
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**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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